

# **Dimensionally Stable High Performance Membrane**

**Han Liu**

**Giner Electrochemical Systems, LLC**

**5/16/2006**

Project ID # FCP 12

This presentation does not contain any proprietary or confidential information

## Overview

### Timeline

- Start – June 2005
- End – March 2006
- 100% Complete

### Barriers

- Freeze/Thaw Durability
- Low RH Operation
- Ionic Conductivity

### Budget

- Total Project Funding: \$100 K
- Funding Received: \$100 K in FY05

## Objectives

- ❑ Develop MEAs based on dimensionally stable membrane (DSM) with high freeze/thaw durability
- ❑ Enhance MEA X-Y (in-plane) dimensional stability
- ❑ Develop MEAs with high ionic conductivity and excellent mechanical properties
- ❑ Demonstrate concept feasibility for membranes based on patterned support

## Approach

### Task 1: Polymer Support Development

- Pattern Design
- Method Validation

### Task 3: Membrane Characterization

- Water Uptake
- Mechanical Properties

### Task 2: Membrane Fabrication

- Direct Insertion
- Ionomer Dispersion Coating
  - Automated Spraying
  - Blade Coating

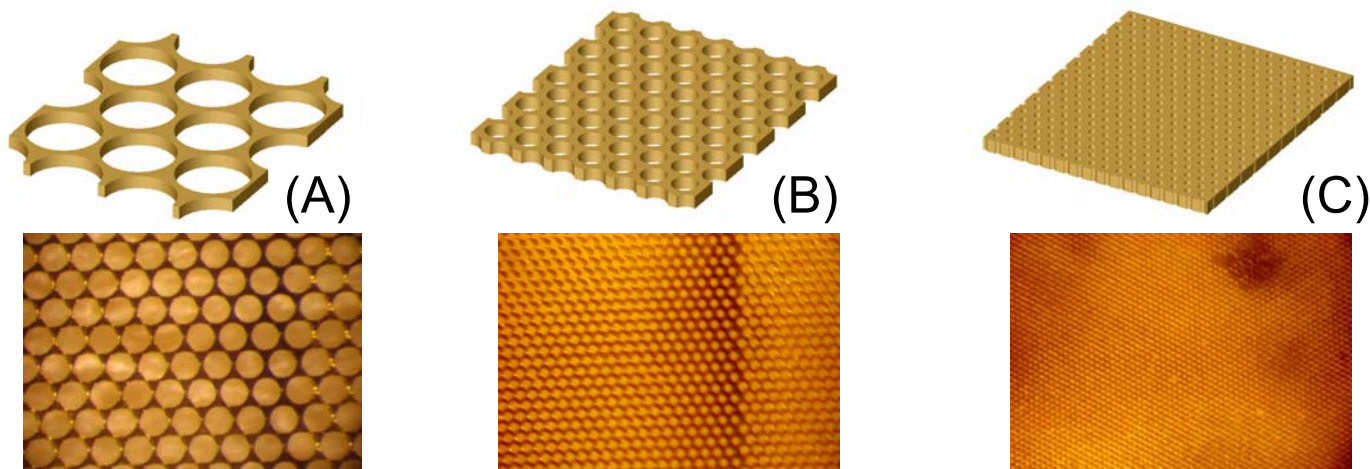
### Task 4: Freeze/Thaw and Performance

- Freeze/Thaw Durability
- Performance Evaluation
- MEA Configuration
- Diffusion Media Type

## Technical Accomplishments/ Progress/Results

- ❑ Supported membranes demonstrate drastically improved freeze/thaw stability compared to Nafion® in *ex-situ* tests.
- ❑ Supported membranes show 10X better in-plane swelling stability than Nafion®.
- ❑ Supported membranes show more than one order of magnitude less creep rate compared to Nafion®.
- ❑ Supported MEA with EW700 ionomer demonstrates superior mechanical properties and 40% performance gain over Nafion®.

## Pattern Design

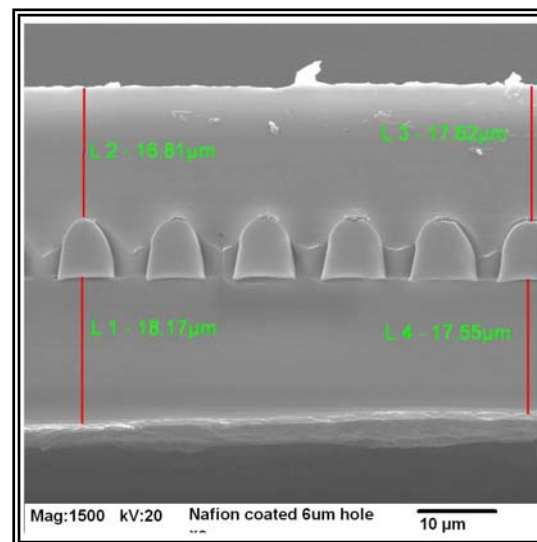
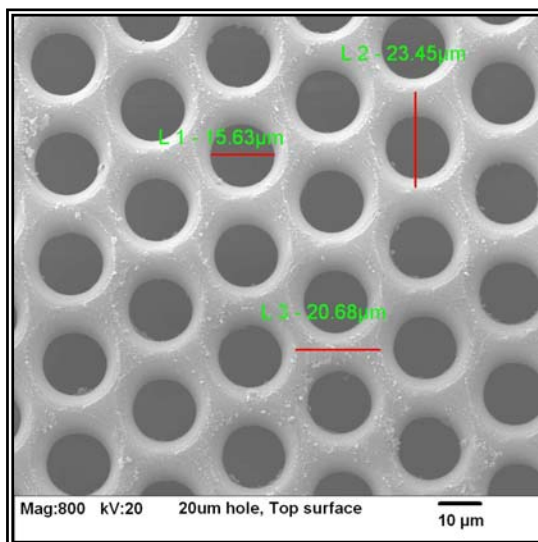


Sample Designation	Hole Diameter ( $\mu\text{m}$ )	Wall Thickness ( $\mu\text{m}$ )	Percentage Opening (%)
A (H70W7)	70	7	75
B (H25W7)	20	7	50
C (H6W7)	6	7	22

**Various support patterns have been successfully fabricated based on Eximer laser technology.**

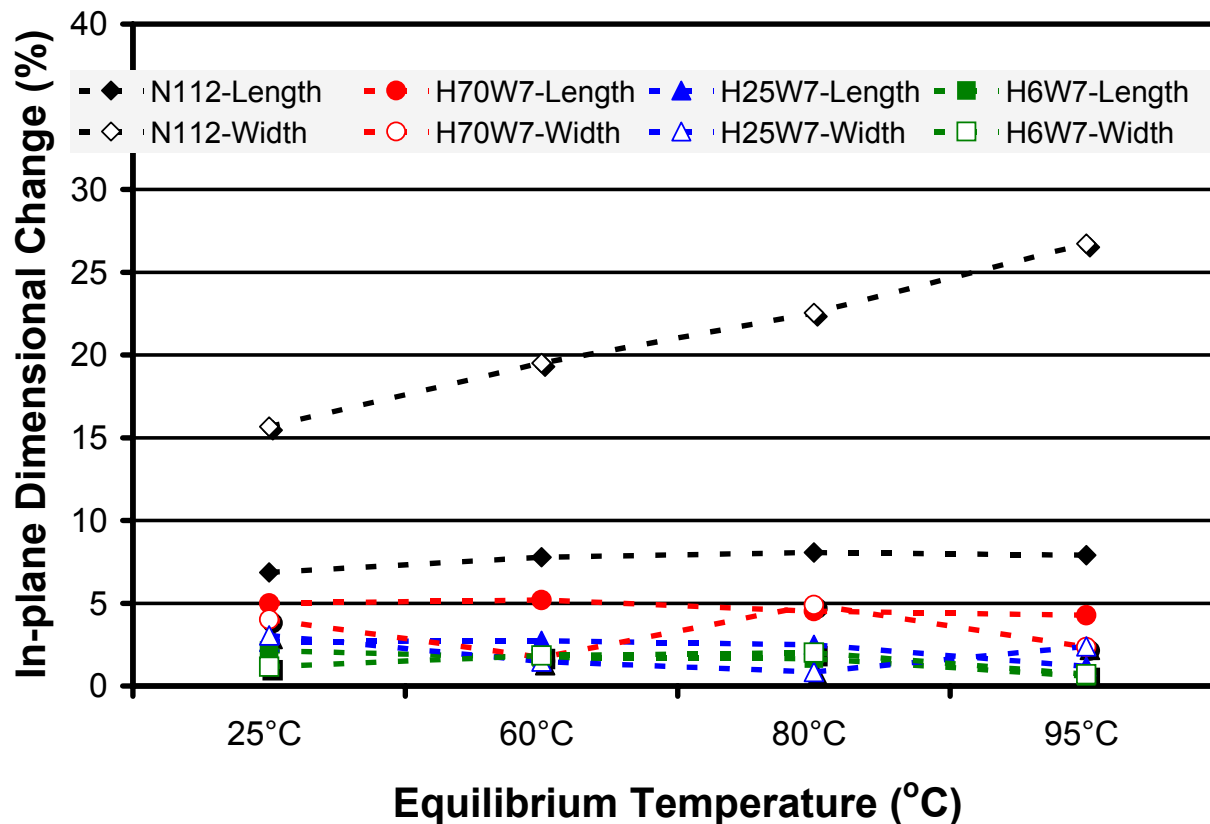
Figures in the top row are schematic illustrations. Figures in the second row are micrographs of the samples.

# Scanning Electron Microscope Images



Based on technology developed at GES, DSMs can be readily fabricated with uniformity better than 5%.

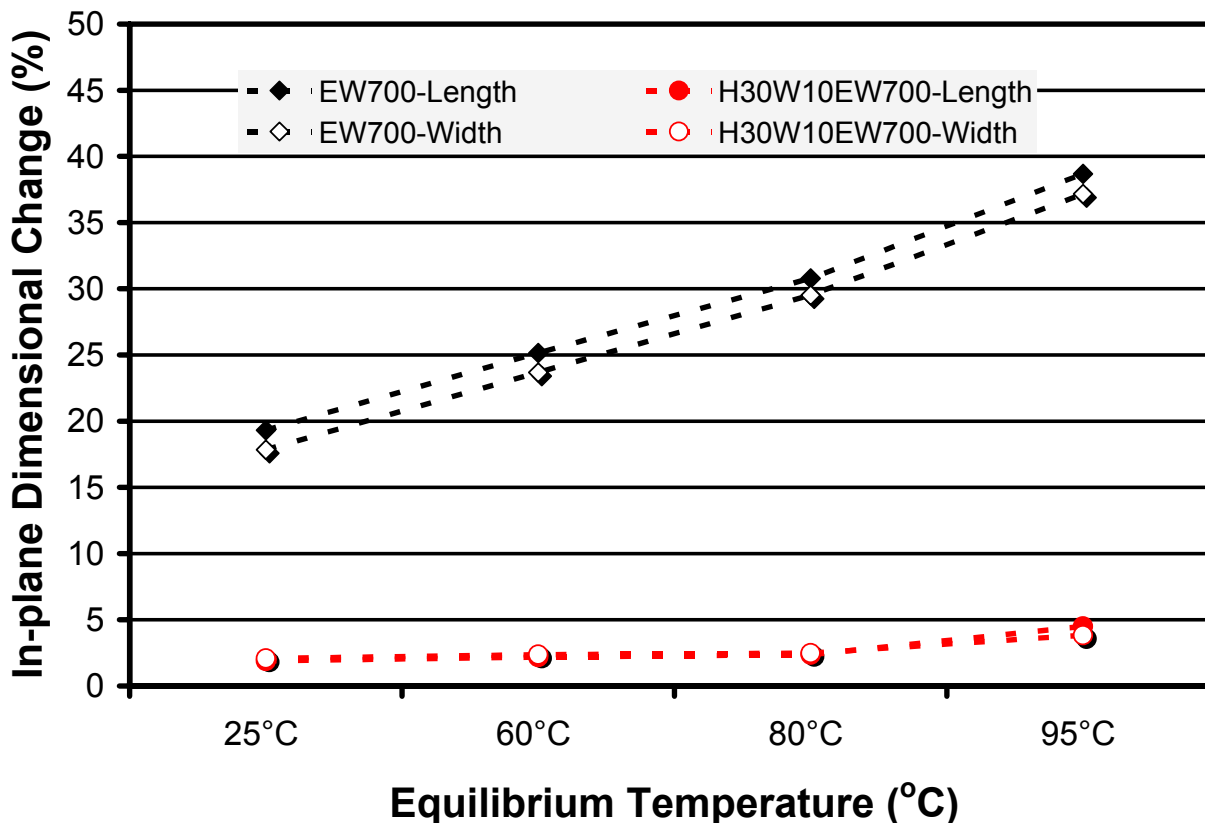
## Swelling Behavior – EW1100



**Compared to Nafion, DSMs demonstrate >10X swelling stability at elevated temperatures when submerged in water.**

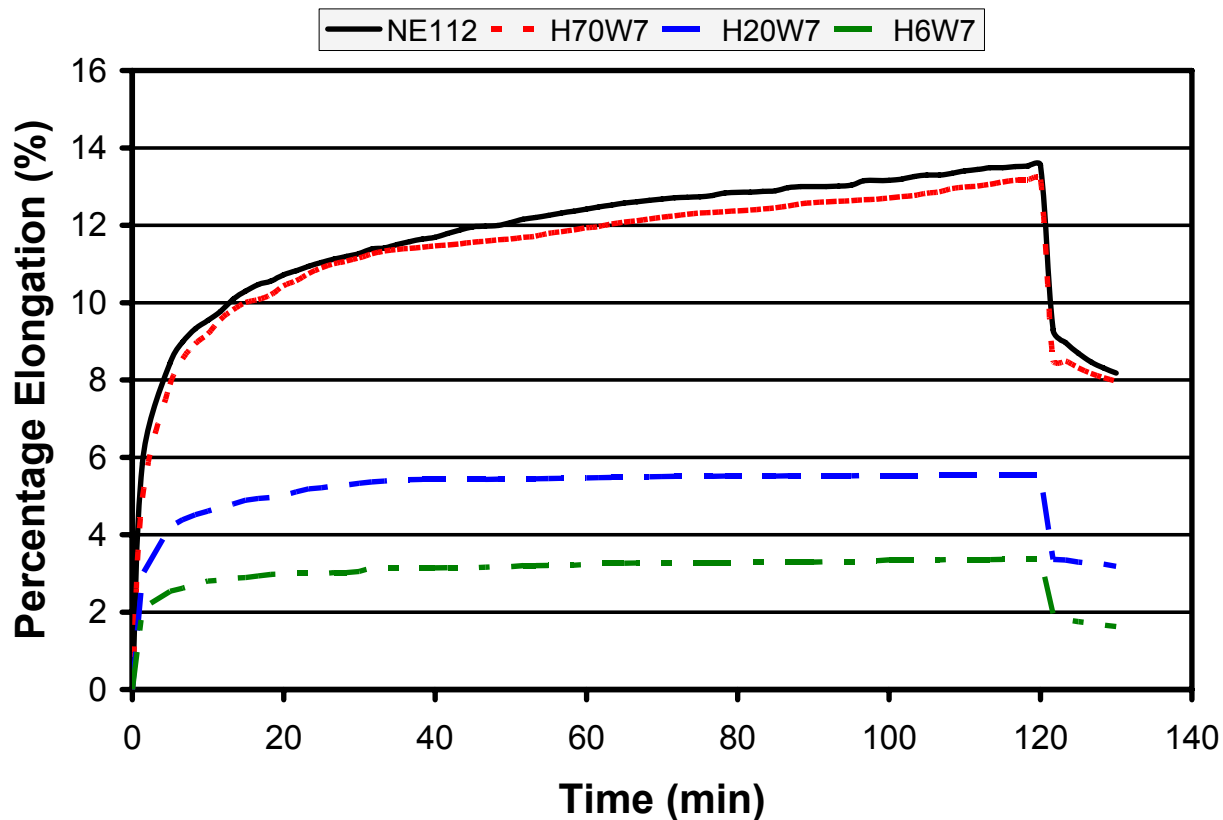


## Swelling Behavior – EW700



**DSM demonstrates extraordinary dimensional stability compared to non-supported EW700 membranes.**

## Creep Behavior



0.5 x 15 mm<sup>2</sup> sample, 80°C, 500 mN force, submerged in DI water.

**Compared to Nafion, DSMs show more than one order of magnitude improvement on creep rate (percentage elongation / hour).**

## Ex-situ Freeze/Thaw Test



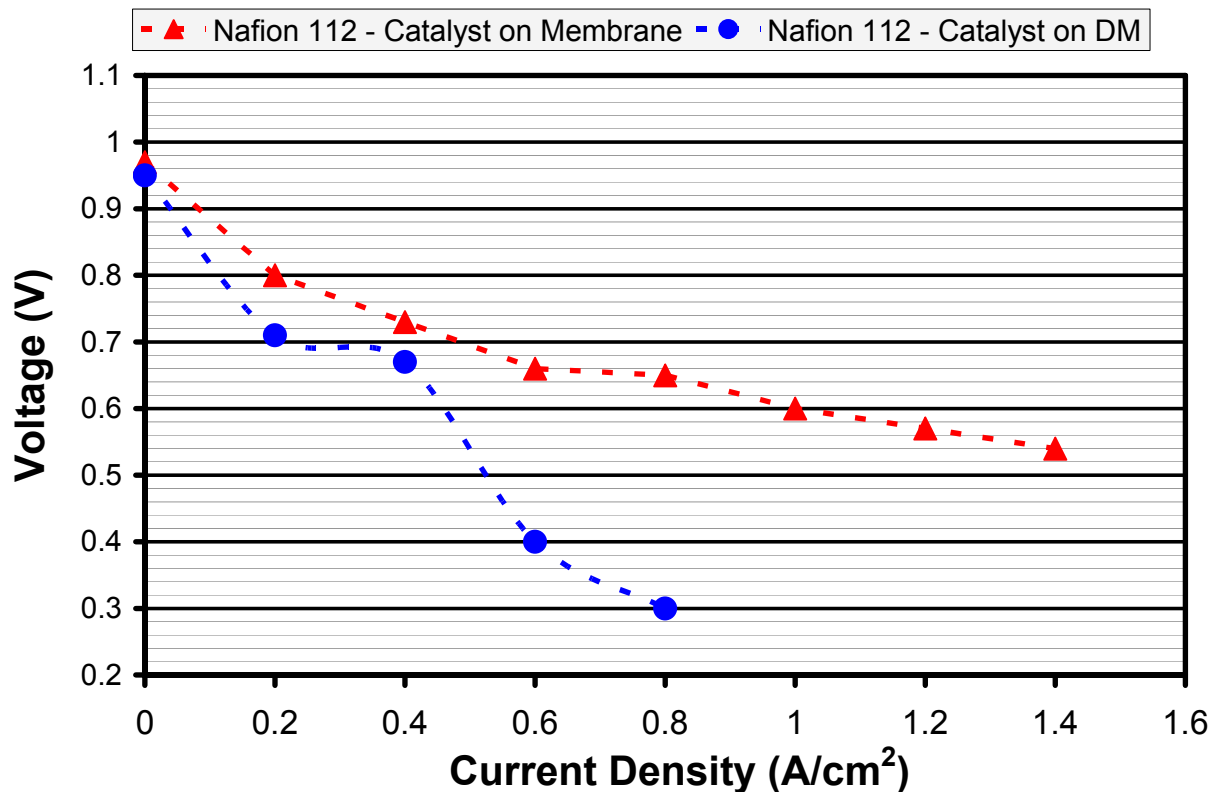
NE112



DSM

**After 10 thermal cycles from  $-40^{\circ}\text{C}$  to  $50^{\circ}\text{C}$  unconstrained, DSM show no observable degradation while Nafion membrane sustained severe damage.**

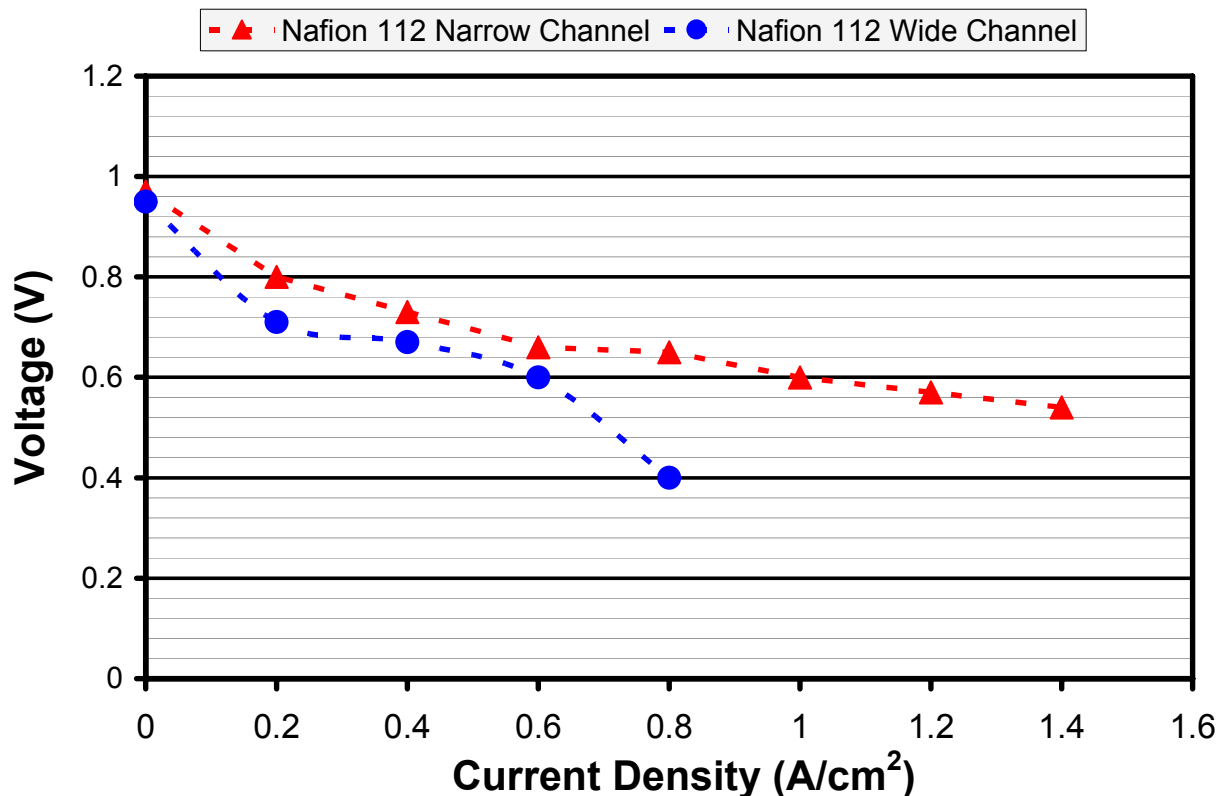
## Impact of MEA Configuration



Reactant Gas: H<sub>2</sub> and air, Pressure: 25 Psi balanced, Temperature: 80°C cell, 64°C (50% RH) air, 80°C (100% RH), Gas Stoic: 4\*, Mode: Constant current (\* Under OCV conditions, the gases supplied at 200 mA/cm<sup>2</sup> equivalent flow.)

**MEA with catalyst on diffusion media performed significantly worse than catalyst on membrane.**

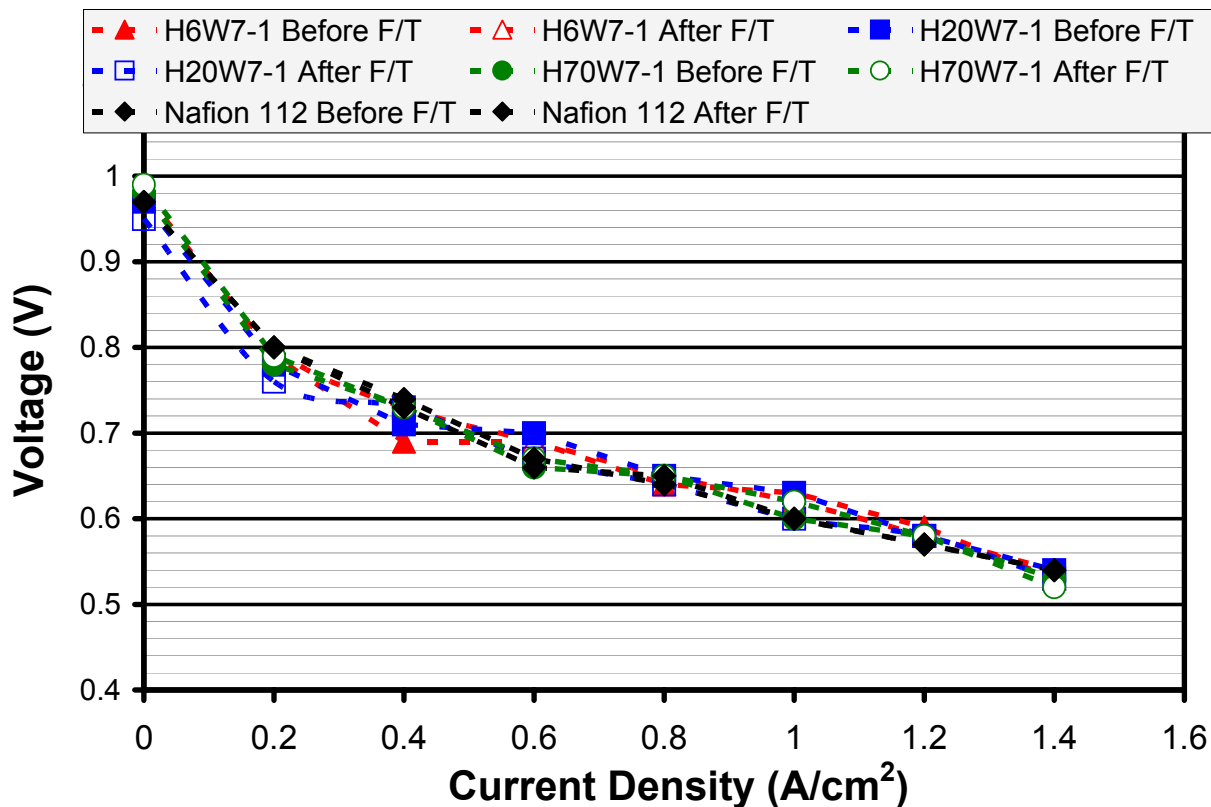
## Impact of Flow Field Geometry



Reactant Gas: H<sub>2</sub> and air, Pressure: 25 Psi balanced, Temperature: 80°C cell, 64°C (50% RH) air, 80°C (100% RH), Gas Stoic: 4\*, Mode: Constant current (\* Under OCV conditions, the gases supplied at 200 mA/cm<sup>2</sup> equivalent flow.)

**Wide flow channels (2 mm) pose water management problems compared to narrow channels (0.9 mm), given the same gas flow rate.**

## Freeze/Thaw Impact on Performance



Reactant Gas: H<sub>2</sub> and air, Pressure: 25 Psi balanced, Temperature: 80°C cell, 64°C (50% RH) air, 80°C (100% RH), Gas Stoic: 4\*, Mode: Constant current (\* Under OCV conditions, the gases supplied at 200 mA/cm<sup>2</sup> equivalent flow.)

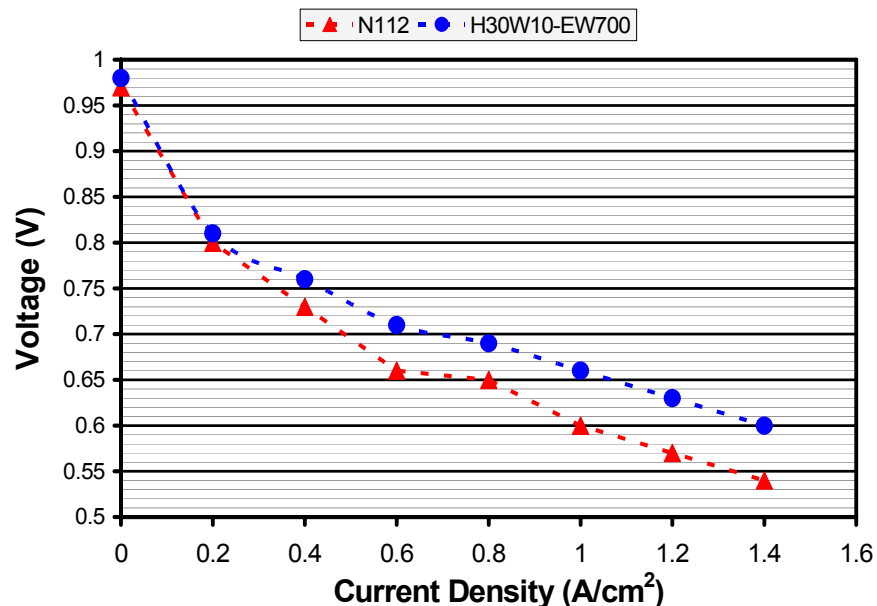
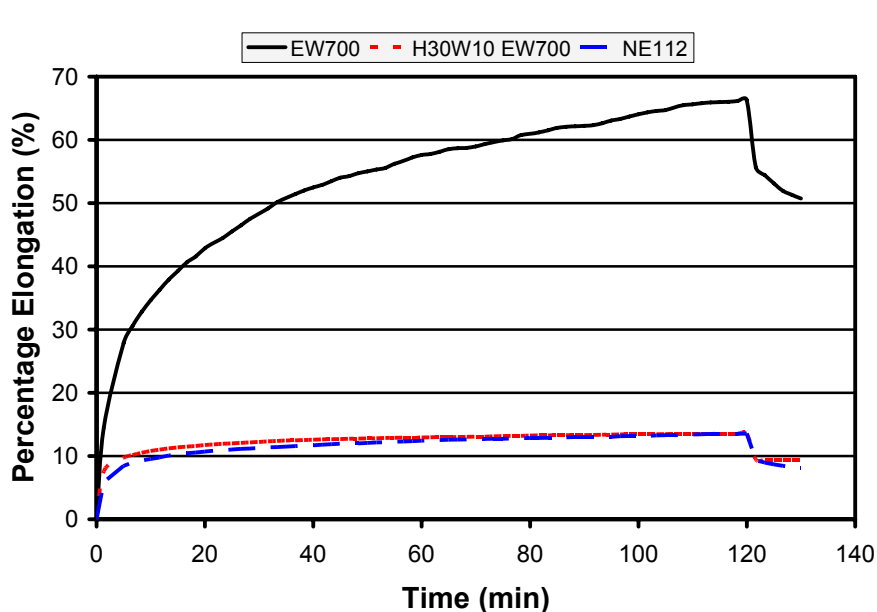
**After 40 thermal cycles from -40°C to 50°C, all MEAs demonstrate excellent stability.**

## Electrochemical Surface Area (ECSA) Test

Sample Designation	ECSA Before Freeze/Thaw (m <sup>2</sup> /g)	ECSA After Freeze/Thaw (m <sup>2</sup> /g)
N112	48	46
H70W7	51	48
H25W7	48	47
H6W7	47	49

**After 40 thermal cycles from -40°C to 50°C, there is no significant drop of ECSA for all MEAs.**

## Performance of EW700 Based MEAs



Reactant Gas: H<sub>2</sub> and air, Pressure: 25 Psi balanced, Temperature: 80°C cell, 64°C (50% RH) air, 80°C (100% RH), Gas Stoic: 4\*, Mode: Constant current (\* Under OCV conditions, the gases supplied at 200 mA/cm<sup>2</sup> equivalent flow.)

**EW700 based DSMs show comparable mechanical properties to Nafion while providing a 40% performance increase. Unsupported EW700 membrane shows unacceptable poor mechanical properties.**



## Future Work – Phase II Work Plan

- ❑ **Freeze/Thaw Test Protocol Development**
  - Number of Cycles
  - Temperature Range
- ❑ **Better Patterning Method**
  - Improve Current Technology
  - Alternative Fabrication Method
  - Alternative Support Material
- ❑ **Local Reinforcement**
  - Identification of Problematic Areas
  - Design and Test Locally Reinforced DSMs
- ❑ **Identify Best MEA Configuration for Freeze/Thaw Durability**
- ❑ **DSM Based Stack Performance Evaluation**

## Summary

- ❑ DSM with high freeze/thaw durability successfully demonstrated in ex-situ tests.
- ❑ Highly uniform DSM successfully developed with projected cost of the patterned support < \$0.02/cm<sup>2</sup>.
- ❑ DSMs show >10X X-Y (in-plane) dimensional stability compared to Nafion membranes.
- ❑ EW700 Based DSM shows a 40% improvement in performance while maintaining comparable/better mechanical properties.

## Filed Patents

**Liu, H., A.B. LaConti, C. Mittelsteadt, T.J. McCallum,** “Solid Polymer Electrolyte Composite Membrane Comprising Laser Micromachined Porous Support,” U.S. Patent Application 20060065521 (March 25 2005).

**Liu, H. and A.B. LaConti,** “Solid Polymer Electrolyte Composite Membrane Comprising Plasma Etched Porous Support,” U.S. Patent Application 20060065522 (March 30, 2005).